Microelectronics User Group Meeting

TWEPP 2011, Vienna, Austria 27/9/2011



| | "News on the 130nm Technology" by Wojciech Bialas (CERN) | (10') |
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| ١ | "Design Toos, Flows and Library Aspects during the FE-I4 Implementation on Silicon" by Vladimir Zivkovic (NIKHEF Institute) | (15') |
| | "Noise and Radiation Hardness of 65nm CMOS Transistors and Pixel Front-Ends" by Massimo Manghisoni (University of Bergamo) | (20') |
| • | Access of 65nm technology through CERN. by Kostas Kloukinas (CERN) | (10') |